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INFORMATION DISCLOSURE				Application Number	10/788,410	CCO. PO
STATEMENT BY APPLICANT				Filing Date	3/1/2004	- SEP 08 2010 W
Date Submitted: September 8, 2010 (use as many sheets as necessary)				First Named Inventor	Robert MARTUZA et a	A ST
				Art Unit	1632	(A)
				Examiner Name	SHEN, Wu Cheng Wil	nston PADEMARY
Sheet	1	of	1	Attorney Docket Number	066683-0198	-

U.S. PATENT DOCUMENTS					
Examin er Initials*	Cite No.1	Document Number  Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code <sup>3</sup> Number Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Documents	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T⁰
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Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.	76
***************************************	H1	Non-Final Office Action USSN 12/194,872 dated June 10, 2010.	-
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Examiner Signature	/Wu-Cheng Winston Shen/	Date Considered	04/05/2011

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